

LEE0023-US



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

SHIH-CHANG CHANG ET AL.

Serial No.: 10/690,703

Filed: OCTOBER 23, 2003

For: SEMICONDUCTOR DEVICE WITH  
LIGHTLY DOPED DRAIN AND  
METHOD OF MANUFACTURING  
THE SAME

Art Unit: 2814

Examiner: PHAM, HOAI V.

**INFORMATION DISCLOSURE STATEMENT FILED UNDER 37 C.F.R. § 1.97(c)(1)**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicants wish to make of record in the above-identified application the document or documents referenced on the attached Form PTO-1449. Copies of the cited references are enclosed herewith. Further, the undersigned hereby certifies that:

- ☒ each item of information contained in the information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement. English language Abstracts are attached with Japanese Laid-Open Patent Publication No. 4-177873 and 2002-050637; or
- ☐ no item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application, and to my knowledge after making reasonable inquiry, no item of information contained in the information disclosure statement was known to any

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individual designated in 37 C.F.R. § 1.56(c) more than three months prior to the filing of the information disclosure statement.

It is respectfully requested that the information be expressly considered during the prosecution of this application, and that each reference be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This submission does not represent that any referenced document is material or constitutes "prior art." If it should be determined that one or more of the referenced documents constitute "prior art" under United States law, Applicants reserve the right to present to the Office the relevant facts and law regarding the appropriate status of the reference or references.

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Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over any referenced document, should it be applied against the claims of the present application.

Any fee necessary for consideration of this Information Disclosure Statement is hereby authorized to be charged to Deposit Account Number 03-3975.

PILLSBURY WINTHROP SHAW PITTMAN LLP

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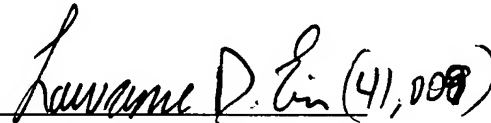
Tel: 703/770-7900

Respectfully submitted,

SHIH-CHANG CHANG ET AL.

Date: February 23, 2006

By:

 (41,000)

for Michael Bednarek

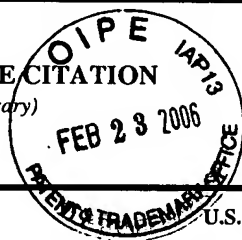
Registration No. 32,329

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# INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)



Docket Number (Optional)

LEE0023-US

Application Number

10/690,703

Applicant(s)

SHIH-CHANG CHANG ET AL.

Filing Date

OCTOBER 23, 2003

Group Art Unit

2814

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
	1	04-177873	06/25/1992	JAPAN				✓
	2	2002-050637	02/15/2002	JAPAN				✓

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

		ENGLISH LANGUAGE ABSTRACTS OF JP H04-177873 AND 2002-050637

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.